



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
<b>KIM et al.</b>	)	Group Art Unit: 2823
	)	
Application No.: 09/574,653	)	Examiner: Hsien Ming LEE
	)	
Filed: May 18, 2000	)	
	)	
For: A TUNABLE SIDEWALL SPACER	)	
PROCESS FOR CMOS	)	
INTEGRATED CIRCUITS	)	

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated August 23, 2004, the period for reply having been extended for one month by a request for extension of time filed concurrently herewith, please amend the application as follows:

**Amendments to the claims** begin on page 2 of this paper.

**Remarks** begin on page 6 of this paper.